



- ☐ Drafts
- ☐ Pending
- ☒ Active
 - ☒ L61: (14514) opto-electronic or opto adj el
 - ☒ L62: (27) 61 and ((substrate with packag\$
 - ☒ L63: (365) 61 and (controller and heat\$3)
 - ☒ L64: (14) 63 and (substrate and bump\$1)
 - ☒ L65: (1) 61 and (electrical adj controller an
- ☐ Failed
- ☒ Saved
 - ☒ (34234) opto-electronic or optical adj switch
 - ☒ (2) (opto-electronic or optical adj switch\$2
 - ☒ (3) (opto-electronic or optical adj switch\$2
 - ☒ (54) (opto-electronic or optical adj switch\$
- ☐ Favorites
- ☐ Tagged (0)
- ☐ UDC
- ☐ Queue
- ☐ Trash

DBs: USPAT US-PGPUB EPO JPO DERWENT IBM_TDB

☐ Plurals

Default operator: OR

☒ Highlight all hit terms initially

(opto-electronic or optical adj switch\$2 or planar adj lightwave adj circuit\$1 or thermo-optic adj switch or opto adj electronic or thermo adj optic adj switch) and ((substrate with packag\$3) and solder adj bump\$1)

☒ BRS 1. ☒ ISLR ☐ Image ☐ Text ☐ HTML

| | U | I | Document ID | Issue Date | Pages | Title | Current OR | Current XRef |
|----|--------------------------|--------------------------|-------------------|------------|-------|--|------------|----------------------|
| 1 | <input type="checkbox"/> | <input type="checkbox"/> | US 20030140698 A1 | 20030731 | 26 | High voltage drive circuitry aligned with MEMS array | 73/514.18 | |
| 2 | <input type="checkbox"/> | <input type="checkbox"/> | US 20030133478 A1 | 20030717 | 23 | Tunable diffractive device | 372/20 | |
| 3 | <input type="checkbox"/> | <input type="checkbox"/> | US 20030131476 A1 | 20030717 | 18 | Heat conduits and terminal radiator for microcircuit packaging and manufacturing | 29/890.03 | 29/557 |
| 4 | <input type="checkbox"/> | <input type="checkbox"/> | US 20030122263 A1 | 20030703 | 5 | Flip-chip opto-electronic circuit | 257/778 | |
| 5 | <input type="checkbox"/> | <input type="checkbox"/> | US 20030122206 A1 | 20030703 | 10 | Multi-chip module integrating MEMS mirror array with electronics | 257/415 | 257/418; 257/419; |
| 6 | <input type="checkbox"/> | <input type="checkbox"/> | US 20030112298 A1 | 20030619 | 31 | Lattice array-structured piezoelectric actuator and method for producing the | 347/68 | |
| 7 | <input type="checkbox"/> | <input type="checkbox"/> | US 20030081287 A1 | 20030501 | 27 | OPTICAL COMMUNICATION SWITCH NODE | 398/52 | 398/45 |
| 8 | <input type="checkbox"/> | <input type="checkbox"/> | US 20030057535 A1 | 20030327 | 17 | Techniques for attaching rotated photonic devices to an optical sub-assembly in an | 257/678 | 257/222 |
| 9 | <input type="checkbox"/> | <input type="checkbox"/> | US 20030038297 A1 | 20030227 | 18 | Apparatus, system, and method for transmission of information between | 257/99 | |
| 10 | <input type="checkbox"/> | <input type="checkbox"/> | US 20030031428 A1 | 20030213 | 11 | Parallel electro-optic interface assembly | 385/89 | 385/88 |
| 11 | <input type="checkbox"/> | <input type="checkbox"/> | US 20030020062 A1 | 20030130 | 28 | MEMS and method of manufacturing MEMS | 257/40 | |

☒ Hit ☐ Details ☐ HTML